



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 1775

SERIAL NUMBER 10/776,338	FILING OR 371(c) DATE 02/12/2004 RULE	CLASS 257	GROUP ART UNIT 2814	ATTORNEY DOCKET NO. 01-549
APPLICANTS Rajesh Kumar, Nagoya-city, JAPAN; Florin Udrea, Cambridge, UNITED KINGDOM; Andrei Mihaila, Cambridge, UNITED KINGDOM;				
** CONTINUING DATA ***** <div style="text-align: right;"><i>NONE, PC</i></div>				
** FOREIGN APPLICATIONS ***** JAPAN 2003-35404 02/13/2003 <i>yes, PC</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/16/2004				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Carmen M. [Signature]</i> <i>PC</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 19
				INDEPENDENT CLAIMS 3
ADDRESS 23400				
TITLE Semiconductor device provided by silicon carbide substrate and method for manufacturing the same				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	